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SERIAL NUMBER 10/669,667	FILING DATE 09/23/2003  RULE	CLASS 117	GROUP ART UNIT 1722	ATTORNEY DOCKET NO. MI22-2144
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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

*None*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

*None*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 12/15/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowed Examiner's Signature <i>[Signature]</i> Initials <i>F.H.</i>	STATE OR COUNTRY ID	SHEETS DRAWING 1	TOTAL CLAIMS 49	INDEPENDENT CLAIMS 3
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ADDRESS  
 021567  
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TITLE  
 Atomic layer deposition methods of forming silicon dioxide comprising layers

FILING FEE  RECEIVED 1402	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
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